

03500.016072.1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
:)
MINEO SHIMOTSUSA, ET AL.)
:)
Application No.: Not Yet Assigned)
:)
Filed: Concurrently Herewith)
:)
For: SEMICONDUCTOR DEVICE,)
:)
METHOD FOR)
:)
MANUFACTURING THE SAME,)
:)
AND LIQUID JET APPARATUS : September 8, 2003

**This application is a divisional
under 37 C.F.R. § 1.53(b) of
U.S. Patent Appln. No. 10/025,674**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CLAIM TO PRIORITY

Sir:

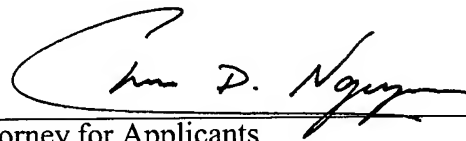
Applicants hereby claim priority under the International Convention and all rights to which they are entitled under 35 U.S.C. § 119 based upon the following Japanese priority applications:

Japan 2000-403335, filed December 28, 2000;
Japan 2001-034045, filed February 9, 2001;
Japan 2001-034046, filed February 9, 2001; and
Japan 2001-034048, filed February 9, 2001.

A certified copy of each of the priority documents was submitted in parent Application No. 10/025,674.

Applicants' undersigned attorney may be reached in our Costa Mesa, California office by telephone at (714) 540-8700. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



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